



ELECTRONIC COPY

LG642459215
Report verification at igi.org



July 9, 2024

IGI Report Number **LG642459215**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.18 X 7.05 X 4.38 MM**

GRADING RESULTS

Carat Weight **1.99 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

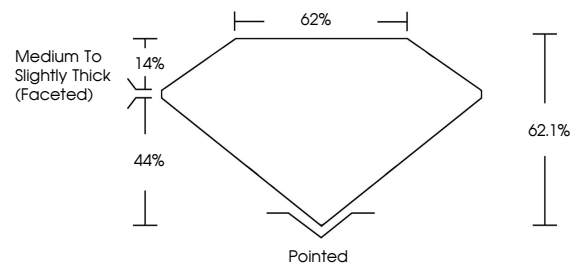
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG642459215**

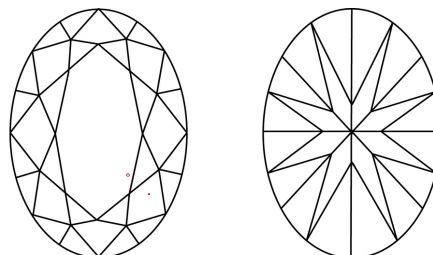
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

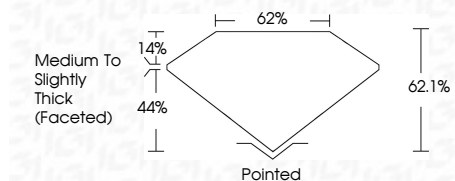
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



ADDITIONAL GRADING INFORMATION

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Symmetry **EXCELLENT**

Fluorescence **NONE**

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IGI



July 9, 2024
IGI Report No **LG642459215**
OVAL BRILLIANT
10.18 X 7.05 X 4.38 MM
Carat Weight **1.99 CARAT**
Color Grade **E**
Clarity Grade **VS 1**
Depth **62.1%**
Table **62%**
Girdle **Medium to Slightly Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG642459215**
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